

PRESSURE SENSITIVE ELEMENT

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Abstract

PROBLEM TO BE SOLVED: To provide a pressure sensitive element in which thickness is made to be thin, manufacturing is facilitated, and no occurrence of failure resulting from an assembling error is allowed.
SOLUTION: A pressure sensitive element is composed of a pressure sensitive film element 20 formed in the center of the bottom face of the dome-like pushing portion 11 of a film 10. The pressure sensitive film element 20 is composed of an electrode pattern 21 formed on the face of the film 10, a pressure sensitive resistant film 25 formed on the electrode pattern 21, an electrode pattern 27 formed on a location opposite to the electrode pattern 21 on the pressure sensitive resistant film 25.

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